

Application/Control No.	Applicant(s)/Patent under Reexamination	er
10/760,276	KIM ET AL.	
Examiner	Art Unit	
Jannelle M. Lebron	2861	

	SEAR	SEARCHED	
Class	Subclass	Date	Examiner

INT	ERFERENC	RENCE SEARCHED	
Class	Subclass	Date	Examiner
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
See attached Search History	7/21/2006	JML